A Dual-Mode Laser-Textured Ice-Phobic Slippery Surface: Low-

Voltage-Powered Switching Transmissivity and Wettability for

Thermal Management

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Figure S1. (a-c) Top-view SEM images with different magnifications for the lasertextured PTFE platform. (d) Oblique view SEM clip for the resulted LA-PTFE. SEM pictures suggest that laser-ablated PTFE is a hybrid of the uniformly-arrayed micropillars together with the micro/nano-porous topography. Accordingly, the superhydrophobic LA-PTFE exhibits remarkable capability of absorption and storage over lubricated paraffin wax depending on a giant capillary force arising from the micro/nano-structures.



Figure S2. (a) 3D images captured by laser microscopy, (b) line-scanning profiles, (c) ablated micro-pillar depth, (d) surface roughness R_a , (e) Optical visibility, and (f) surface wetting evolution for the six LA-PTFE platforms that were manufactured with fs laser scanning intervals of 0.05, 0.1, 0.15, 0.2, 0.25 and 0.3 mm, respectively. Considering that, a robust slippery surface requires a superhydrophobic porous and reflective platform. In this regard, we select an optimized LA-PTFE ablated with an interval of 0.10, which exhibits an excellent hydrophobicity as well as a moderate light-reflectivity.



Figure S3. EDS mapping for displaying the evolution over the relative atomic ratio of F and C elements in (a) the pristine PTFE and (b) the laser-ablated PTFE. The decrease of C element in LA-PTFE evidenced that fs laser manufacturing technique is not only competent for ablating highly arrayed micro-pillars, but also responsible for inducing a large amount of nano-porous morphology.



Figure S4. 3D imaging photos for the laser-textured PTFE substrate with the interval of 0.15 mm (a) with and (b) without paraffin impregnation. (c) Line scanning profiles for the as-prepared LA-PTFE and the paraffin-impregnated LA-PTFE. By subtracting the paraffin-impregnated LA-PTFE by the LA-PTFE counterpart, we can harvest the thickness of the impregnated paraffin, which is roughly estimated as 33.5 μ m.



Figure S5. Measurements of (a) sheet resistance and (b) transmittance in a wavelength range of 180-1400 nm for the silver nanowires woven thin-film heater. The result shows that current heater is highly transparent and conductive for serving as a flexible/portable electric-induced-heating source.



Figure S6. Digital pictures for displaying (a) the planar and (b) the bent electricpowered DM-SLIPS. (c) SEM clip for characterizing the architecture of DM-SLIPS composed of top-layer paraffin-impregnated LA-PTFE, middle-layer adhesive tape and bottom-layer silver nanowires thin-film heater. They have the identical thickness of ~100 μ m, signifying the DM-SLIPS has a total height of ~300 μ m.



Figure S7. Time-lapse clips for displaying the typical droplet $(10 \ \mu L)$ sliding behavior on DM-SLIPS without (left one) and with (right one) Joule-heat. The result showcasing that the rough ASS system presents ultra-adhesive force and the smooth ALS system unfolds a lower hysteresis.



Figure S8. Quantitative measurements for recording the f_{LL} and f_{SL} over diverse liquids on horizontal charging/discharging DM-SLIPS, including water, glycerol, ethylene glycol (EG) and dimethyl formamide (DMF).



Figure S9. Transmittance spectrums for pristine PTFE, laser-ablated PTFE, and DM-SLIPS with and without Joule-heat. The DM-SLIPS has a minimum transparency compared to the pristine PTFE and LA-PTFE, thereby displaying a best cooling performance. In addition, light irradiating on DM-SLIPS can be switched between release mode and lock mode so as to realizing the controllable solar energy input according to the user's request.



Figure S10. (a) Reflectance spectrum in a wavelength range of 180-1400 nm and (b) Transmittance spectrum in a wavelength range of 2-25 μ m. The result unfolds that silver nanowire thin-film heater is a transparent feature in the visible range but a reflective appearance in the MIR scope (8-13 μ m), signifying the thermal insulation property assigned on DM-SLIPS is derived from the embedded silver nanowires with far smaller IR emittance (~0.03). In ultra-cold winter, the electricity-induced Joule-heat could replenish the indoor temperature and meanwhile the release mode of electric-powered DM-SLIPS allows the solar energy entrance but reject its leakage towards outer space (lower IR emittance), so these merits enable DM-SLIPS to cope with energy crisis in some special regions having extremely-cold climates.



Figure S11. Digital photograph for the home-made system for a proof-of-concept thermal management, which is composed of a computer-connected thermal IR imager, an electric power source, 808 nm laser and a piece of Fe_3O_4 -doped PDMS membrane. By loading/discharging the electric-stimuli, the DM-SLIPS is finely-tuned between transparent and opaque for controlling the solar energy input on demand.



Figure S12. Temperature-time curve of DM-SLIPS recorded by Joule heating from its minimum frozen state to the ice melting state.



Figure S13. (a) Digital clips for evidencing the reversible transparency switching through cyclic heating/freezing operations. (b) A proposed mechanical model for the liquefied paraffin dwelling on an erect DM-SLIPS. (c) 3D laser profiles for verifying the durability of DM-SLIPS suffering from cyclic heating/freezing maneuvering.



Figure S14. The upper schematic diagram displaying the home-made flexibility test system and the lower digital clips presenting the good apparent flexibility of electric-loading DM-SLIPS; The scale bar is 1 cm.

(1) Cost Analysis for LA-PTFE						
<u>Fs Laser ablation (including</u> laser, water-cooling and air conditioner systems, 6 kW)		Time-cost for processing 6×6 cm ² LA-PTFE (1.5 h)		Electric charge (1.5 ¥ /kW⋅h)		Cost 1: 6 kW×1.5 h×1.5 ¥/kW·h = 13.5 ¥
(2) Cost Analysis for paraffin lubrication						
Paraffin wax ~ 0.03g×0.809 ¥ / g =0.024 ¥	Thermal-spin-coating period (60 s),power (0.07 kW)		Electric charge (1.5 ¥ /kW⋅h)		Cost②:0.024 ¥ +0.07 kW×0.0166 h×1.5 ¥ /kW⋅h = 0.0357 ¥	
(3) Cost Analysis for silver nanowire coating and Bonding						
$ \begin{array}{l} \underline{Synthesize \ silver \ nanowires \ (16 \ mg):} & (Materials \ expenses) & (NaCl) \ 0.0613 \ g \times 0.031 \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \$						
Silver nanowires ink (16 mL, 1mg/mL): 32 mg HPMC+Sago-dispersant (v/v 0.0025%)+Sago-flatting agent (v/v 0.0025%) ≈ 0.06 ¥ ;						
Silver nanowire heater bonding (6×6 cm ²): PET film (6×6 cm ²) = 0.0005 ¥; PDMS adhesive layer ≈ 0.004 ¥; Silver paste for electrodes ~2 mg×0.013 ¥/mg=0.026 ¥; Here, the material expense for 1 mL SNW ink is $5.7815 \pm /16$ mL ≈ $0.36 \pm /mL$ and thus the material cost for preparing 1 cm ² silver nanowire film is calculated as $0.36 \pm divided$ by (21.0×29.7 cm ²), that is, $0.0006 \pm /cm^2$. Accordingly, the cost for silver nanowire heater with area of 6×6 cm ² is 0.0216 ¥; Electric charge for oven heating 7h×0.6kW×1.5 $\pm /kW \cdot h=6.3 \pm$						
Total Cost Analysis						
13.5 ¥ (electric charge-LA-PTFE)+ 0.0357 ¥ + 3.75 ¥ (electric charge-oil bath)+ 0.0005 ¥ (PET platform)+ 0.004 ¥ (PDMS adhesive layer for bonding)+ 0.0216 ¥ (material expense for silver papewires film)+ 6.3 ¥ (electric charge for beging oven)+ 0.026 ¥ (silver paste) = 23.6 ¥ = 3.7 \$						

Figure S15. Cost analysis over a typical DM-SLIPS (6 cm×6 cm) by combining the Fs

laser scanning technique



Figure S16. Schematic diagram for showing the influence of laser-cutting parameters on the topographical and optical evolution of DM-SLIPS.